

ABSTRACT

A cosmetic procedure device control method is disclosed. The cosmetic procedure device control method according to one aspect of the present invention
5 comprises: a skin suction step of forming negative pressure in a suction space so as to suction the skin into the suction space; a skin height detection step of detecting the height of the skin suctioned into the suction space; and a high frequency application determination step of determining whether to operate a high frequency application unit according to the height of the skin determined in the skin height detection step, wherein
10 the skin height detection step detects which electrode end is in contact with the skin and conducts electricity from among a plurality of electrode ends of the high frequency application unit.

FIG. 10